

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 1750**

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hisaji Oyake et al.
Application No. : 10/507,429
Filed : September 10, 2004
For : METHOD FOR PROCESSING A PHOTORESIST-COATED
GLASS BOARD, A METHOD FOR MANUFACTURING A
STAMPER FOR A RECORDING MEDIUM, A METHOD FOR
MANUFACTURING A RECORDING MEDIUM, A
PHOTORESIST-COATED GLASS BOARD, A STAMPER FOR A
RECORDING MEDIUM, AND A RECORDING MEDIUM

Examiner : Martin J. Angebranndt
Art Unit : 1756
Docket No. : 890050.503USPC
Date : April 17, 2007

OK to
Enb
WA
4/25/07
Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.116

Commissioner for Patents:

In response to the Office Action dated February 5, 2007, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 8 of this paper.